

Notice of References Cited	Application/Control No. 10/736,260	Applicant(s)/Patent Under Reexamination HALWAN ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	J	US-			
	K	US-			
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	M	US-			

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	U	
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	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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